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Substitute for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	10/688,186 – Conf. #4125
				Filing Date	September 24, 2003
				First Named Inventor	Yutaka TAKAFUJI
				Art Unit	2813
				Examiner Name	MENZ, Laura Mary
Sheet	1	of	1	Attorney Docket Number	1248-0673P

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	AA*	US-2002/0047169*	04-25-2002	Kunikiyo	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ²
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	BA	JP-06-289421	10-18-1994	Matsushita Electric Ind. Co. Ltd.		✓
	BB	JP-2002-076336	03-15-2002	Mitsubishi Electric Corp.		ABS

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	C. GUI et al., "The effect of surface roughness on direct wafer bonding," Journal of Applied Physics, May 15, 1999, Volume 85, No. 10, pp. 7448-7454	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*) corresponding to JP 2002-76336A (BB)

Date: November 26, 2008

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